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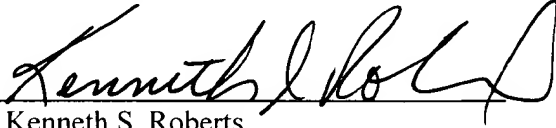
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Applicants include on a separate sheet attached hereto a marked version showing the amendment to the specification.

Respectfully submitted,

LYON & LYON LLP

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By:   
Kenneth S. Roberts  
Reg. No. 38,283



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LYON & LYON LLP  
633 W. Fifth Street, Suite 4700  
Los Angeles, CA 90071